

<b>FORM PTO-1449</b> <b>INFORMATION DISCLOSURE STATEMENT</b>	Atty. Docket  MAE 296	Application No.  10/690,579
	Applicant Noriyuki MIURA	
	Filing Date October 23, 2003	Group 2811

**U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Sub-Class	Translation
DF	AI	5-235350	09/10/93	JAPAN			Abstract
7	AJ	7-162011	06/23/95	JAPAN			Abstract
2	AK	650 190 A1	04/26/95	EUROPE			N/A
	AL						
	AM						
	AN						

**OTHER (Including Author, Title, Date, Pertinent Pages, etc.)**

	AO	
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Examiner

Date Considered

9/22/01

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

<b>FORM PTO-1449</b>  <b>INFORMATION DISCLOSURE STATEMENT</b>		Atty Docket <b>MAE 296</b>		Application No. <b>To Be Assigned</b>	
		Applicant <b>Noriyuki MIURA</b>			
		Filing Date <b>October 23, 2003</b>		Group Unit <b>To Be Assigned</b>	

U.S. PATENT DOCUMENTS							
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	AA						
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	AE						
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FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
<i>PF</i>	AH	2001-284590	10/12/01	Japan			Abstract
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						


OTHER (Including Author, Title, Date, Pertinent Pages, etc.)		
<i>PF</i>	AO	Su et al., "Optimization of Series Resistance in Sub-0.2 $\mu$ m SOI MOSFETs", 1993, IEDM 93, p723-726.
	AP	
	AQ	
	AR	

Examiner <i>[Signature]</i>	Date Considered <i>9/22/06</i>
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				Filing Date October 23, 2003		Group 2891	
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Sub-Class	Translation
DP	AI	11-330475	11/30/1999	JAPAN			Abstract
→	AJ	08-148679	06/07/1996	JAPAN			Abstract
✓	AK	11-195789	07/21/1999	JAPAN			Abstract
✓	AL	10-247734	09/14/1998	JAPAN			Abstract
	AM						
	AN						
<b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AO						
Examiner 					Date Considered <u>9/26/06</u>		
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